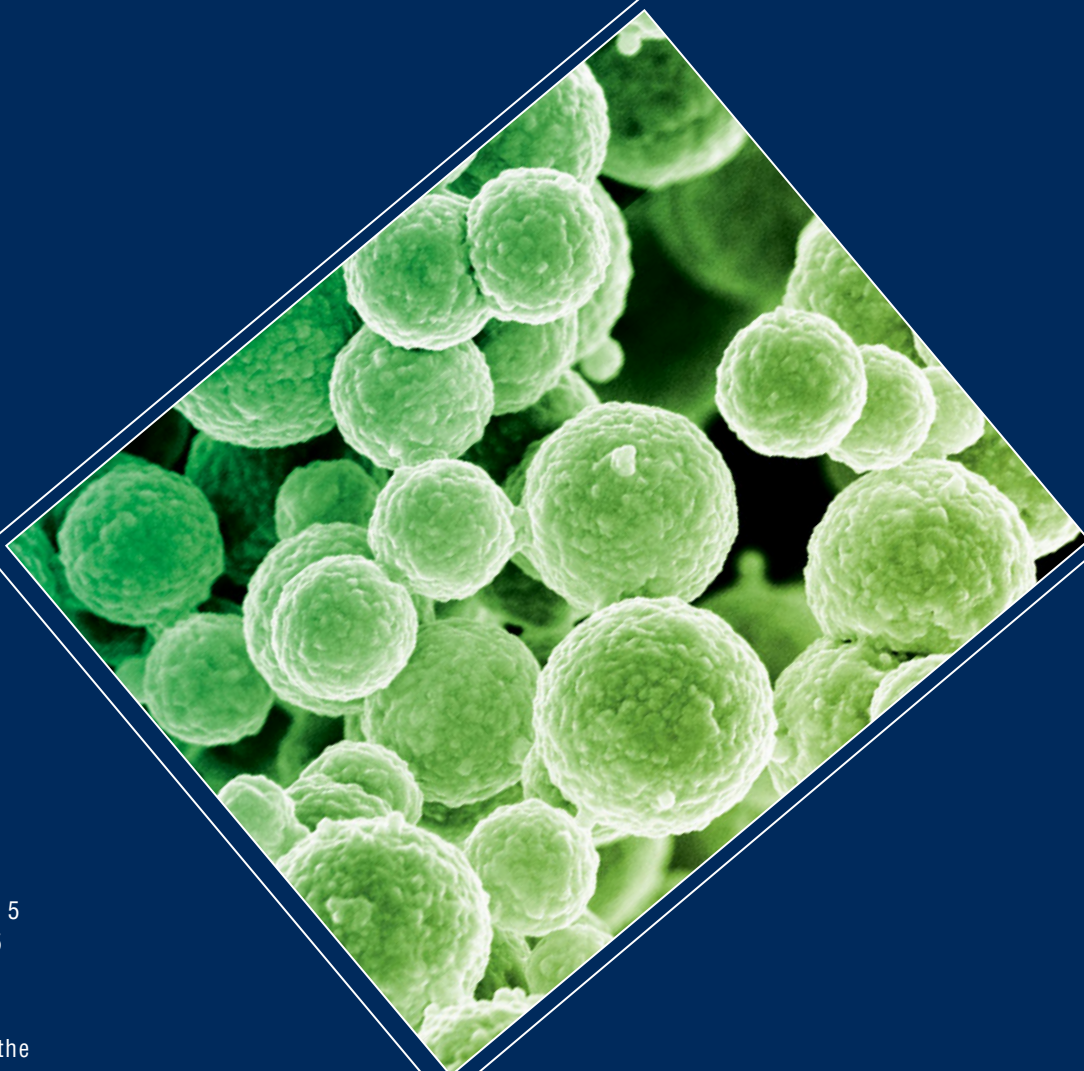


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 **Journal of
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Journal of MATERIALS RESEARCH

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Cover: FIG. 3(d). FESEM image of pure AgBr, Ag@AgBr microspheres synthesized at S-5. [C. Wu: Facile room temperature synthesis of Ag@AgBr core-shell microspheres with high visible-light-driven photocatalytic performance. p. 677].

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